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Response Under 37 C.F.R. § 1.116 -  
Expedited Procedure - Examining Group 1722

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

Group Art Unit: 1722

Janis Virbulis et al.

Examiner: Matthew J. Song

Serial No.: 10/053,446

Filed: January 17, 2002

For: PROCESS AND APPARATUS FOR PRODUCING A  
SILICON SINGLE CRYSTAL

Attorney Docket No.: WSAG 0128 PUS

**RESPONSE UNDER 37 C.F.R. § 1.116**

Mail Stop AF  
Commissioner for Patents  
U.S. Patent & Trademark Office  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action mailed April 4, 2005, please amend the  
above-identified application as follows:

**CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8**

I hereby certify that this paper, including all enclosures referred to herein, is being deposited with the United States Postal Service as first-class mail, postage pre-paid, in an envelope addressed to: Mail Stop AF, Commissioner for Patents, U.S. Patent & Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450 on:

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